SOS GROUP

LAM Research

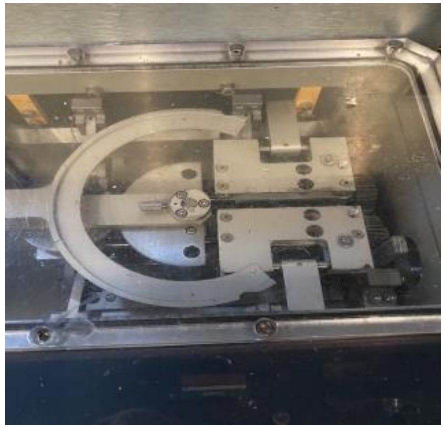
490 AutoEtch Plasma Etch 150mm Configuration

Serial NR: 9164

Contact? Click here

LAM 490 AutoEtcher
- Polysilicon: 490
- Wafer size: 6 inch
- Upgraded TFT monitors
- Incl maintenance console
- Conditon: AS IS (No Chiller, No pump but with ENI RF Generator)

Features:
- Single-wafer processing
- Fully automated microprocessor control •Cassette-to-cassette wafer processing
- Vacuum load locked
- Programmable, variable electrode spacing •Endpoint detection
- Configurable for 3-inch to 6-inch wafers
- Stand-alone or bulk-head mount configuration



Lam RESEARCH

SERIAL No. 9164

MODEL No. 490

10.000 AIC

50-~~60~~ HERTZ

	RAINBOW	TCP	OTHER
VOLTAGE	208	208	208
PHASE	3	3	3
CURRENT	30	80	30
CONNECTION	WYE	WYE	WYE